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Docket No.: APA-0216  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Hideki Morita, et al.

Application No.: 10/507,325

Confirmation No.: 2850

Filed: September 10, 2004

Art Unit: 1731

For: Method and Apparatus for Processing Brittle  
Material

Examiner: Not Yet Assigned

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. APA-0216 from which the undersigned is authorized to draw.

Dated: June 26, 2006

Respectfully submitted,

By 

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